

UNITED STATES PATENT AND TRADEMARK OFFICE



DATE MAILED: 05/09/2002

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/932,754	08/17/2001	Emil Kamieniecki	QCS-001DV3 5384		
21323	7590 05/09/2002				
TESTA, HURWITZ & THIBEAULT, LLP			EXAMINER		
HIGH STREE	REET	HOLLINGTON, JERMELE M			
BOSTON, M.	A 02110		ART UNIT	PAPER NUMBER	
			2829		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.		Applicant(s)	
		09/932,754		KAMIENIECKI ET AL.	
•	Office Action Summary	Examiner		Art Unit	
		Jermele M. Hollir	ngton	2829	
Period fo	The MAILING DATE of this communication app or Reply	ears on the cover	sheet with the c	orrespondence addr	ess
A SHO THE N - Exter	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication.	86(a). In no event, howe	ever, may a reply be tim	ely filed	
- If NO - Failui - Any r	period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period we to reply within the set or extended period for reply will, by statute, eply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	vill apply and will expire to cause the application to	SIX (6) MONTHS from to become ABANDONED	he mailing date of this comr	munication.
1)⊠	Responsive to communication(s) filed on 17 A	lugust 2001 .			
2a)	This action is FINAL . 2b)⊠ Thi	is action is non-fi	nal.		
3) Disposition	Since this application is in condition for allowa closed in accordance with the practice under to on of Claims				merits is
4) 🖂	Claim(s) 53-57 is/are pending in the applicatio	n.			
4	4a) Of the above claim(s) is/are withdraw	vn from considera	ation.		
5)	Claim(s) is/are allowed.				
6)⊠	Claim(s) <u>53-57</u> is/are rejected.				
7)	Claim(s) is/are objected to.				
	Claim(s) are subject to restriction and/or on Papers	election require	ment.		
9) 🗆 🗆	The specification is objected to by the Examiner				
10) 🔲 7	Γhe drawing(s) filed on is/are: a)□ accep	ted or b) objecte	ed to by the Exan	niner.	
	Applicant may not request that any objection to the	drawing(s) be held	d in abeyance. Se	e 37 CFR 1.85(a).	
11) 🔲 🏾	The proposed drawing correction filed on	is: a) ☐ approve	d b) disapprov	ved by the Examiner.	
	If approved, corrected drawings are required in rep	ly to this Office act	ion.		
12) 🔲 T	The oath or declaration is objected to by the Exa	aminer.			
Priority u	nder 35 U.S.C. §§ 119 and 120				
13) 🗌	Acknowledgment is made of a claim for foreign	priority under 35	U.S.C. § 119(a)	-(d) or (f).	
a)[☐ All b)☐ Some * c)☐ None of:				
	1. Certified copies of the priority documents	have been rece	ived.		
	2. Certified copies of the priority documents	have been rece	ved in Applicatio	n No	
	3. Copies of the certified copies of the prior application from the International Bur ee the attached detailed Office action for a list of the company of the certification of the prior action for a list of the certification of the certification of the prior action for a list of the certification of the prior action for a list of the certification of the prior action of the prior acti	eau (PCT Rule 1	7.2(a)).		age
	cknowledgment is made of a claim for domestic				oplication).
•	☐ The translation of the foreign language pro	•	- , .		F
	cknowledgment is made of a claim for domestic				
Attachment	(s)				
2) Notice	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s) <u>3</u> .	5) 🔲		(PTO-413) Paper No(s). atent Application (PTO-1	
S. Patent and Tra TO-326 (Rev		tion Summary		Part of Pa	aper No. 4

Application/Control Number: 09/932,754

Art Unit: 2829

DETAILED ACTION

Claim Objections

1. Claim 53 is objected to because of the following informalities: in line 10, "said surface voltage sensor" should be --said surface photovoltage sensor--. Appropriate correction is required.

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 3. Claims 53-57 are rejected under 35 U.S.C. 102(b) as being anticipated by Kamieniecki et al (5091691).

Regarding claim 53, Kamieniecki discloses [see fig. 17] an apparatus for making surface photovoltage measurements of a semiconductor comprising a sealed chamber (represented as enclosure 197) [see column 12 lines 15-19] for processing the semiconductor wafer (represented as specimen 11) [see column 4 lines 34-37 and column 6 lines 32-36] and a head assembly (represented as reference electrode assembly 199) having a modulated light source (43) inherently exposing at least a portion of the semiconductor wafer (11) to light having a wavelength and modulated at a frequency [see column 7 lines 29-35 and lines 49-62 and column 12 lines 39-42] and a surface photovoltage sensor (represented as reference electrode 203) inherently detecting a surface photovoltage induced at the surface of the semiconductor wafer (11) in response to the light [via light source 43] without contacting the wafer (11) [see column

Application/Control Number: 09/932,754

' Art Unit: 2829

12 lines 39-50], wherein the photovoltage is used to calculate an electrical property of the semiconductor wafer (11) [see Abstract], said surface photovoltage sensor (203) of head assembly (199) located within the sealed chamber (197).

Regarding claims 54-56, Kamieniecki inherently discloses the sealed chamber (197) as a reduced pressure chamber, a chemically reactive gas chamber or an inert environment chamber [see column 12 lines 15-16 and column 13 lines 42-46].

Regarding claim 57, Kamieniecki discloses [see fig. 17] the head assembly (199) is entirely located within the sealed chamber (197).

Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Lagowski (5369495), Lowell et al (5963783) and Hause et al (6166354) disclose a method and apparatus for testing of a semiconductor wafer.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jermele M. Hollington whose telephone number is (703) 305-1653. The examiner can normally be reached on M-F (9:00-3:30 EST) First Friday Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Sherry can be reached on (703) 308-1680. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7382 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-1782.

Application/Control Number: 09/932,754

' Art Unit: 2829

JMH May 5, 2002 Jermele M. Hollington Examiner Art Unit 2829

Mihales 5/6/02

> MICHAEL SHERRY SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800